

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	CORRECTIVE ASSIGNMENT										
NATURE OF CONVEYANCE:	Corrective Assignment to correct the typographical error in application no. from '11/793,515' to read --12/793,515-- previously recorded on Reel 024781 Frame 0403. Assignor(s) hereby confirms the assignnor's interest.										
CONVEYING PARTY DATA											
<table border="1"><thead><tr><th>Name</th><th>Execution Date</th></tr></thead><tbody><tr><td>Carlos MAZURE</td><td>05/25/2010</td></tr><tr><td>Richard FERRANT</td><td>06/03/2010</td></tr><tr><td>Konstantin BOURDELLE</td><td>05/18/2010</td></tr><tr><td>Bich-Yen NGUYEN</td><td>05/19/2010</td></tr></tbody></table>		Name	Execution Date	Carlos MAZURE	05/25/2010	Richard FERRANT	06/03/2010	Konstantin BOURDELLE	05/18/2010	Bich-Yen NGUYEN	05/19/2010
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Richard FERRANT	06/03/2010										
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Bich-Yen NGUYEN	05/19/2010										
RECEIVING PARTY DATA											
Name:	S.O.I.TEC SILICON ON INSULATOR TECHNOLOGIES										
Street Address:	Parc Technologique des Fontaines										
City:	F-38190 Bernin										
State/Country:	FRANCE										
PROPERTY NUMBERS Total: 1											
<table border="1"><thead><tr><th>Property Type</th><th>Number</th></tr></thead><tbody><tr><td>Application Number:</td><td>12793515</td></tr></tbody></table>		Property Type	Number	Application Number:	12793515						
Property Type	Number										
Application Number:	12793515										
CORRESPONDENCE DATA											
Fax Number:	(212)294-4700										
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>											
Phone:	2122946635										
Email:	dkumar@winston.com										
Correspondent Name:	WINSTON & STRAWN LLP - Allan A. Fanucci										
Address Line 1:	1700 K Street, N.W.										
Address Line 4:	Washington, DISTRICT OF COLUMBIA 20006-3817										
ATTORNEY DOCKET NUMBER:	4717-31200										
NAME OF SUBMITTER:	ALLAN A. FANUCCI										
Total Attachments: 8											

501254309

PATENT
REEL: 024796 FRAME: 0570

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PATENT ASSIGNMENT

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08/03/2010
501251448

SUBMISSION TYPE:	NEW ASSIGNMENT										
NATURE OF CONVEYANCE:	ASSIGNMENT										
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NAME OF SUBMITTER:	ALLAN A. FANUCCI										
Total Attachments: 4 source=4717-31200-Assignment#page1.tif source=4717-31200-Assignment#page2.tif											

CH \$40.00 11793515

TO: WINSTON & STRAWN LLP - ALLAN A. FANUCCI COMPANY: 1700 K STREET, N.W.

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ASSIGNMENT

WHEREAS, each of

Carlos Mazure, a citizen of Germany residing at
143 Chemin Du Bas Bernin, Residence Cidex 64a,
Bernin, France 38190,

Richard Ferrant, a citizen of France residing at
Village Desuguensou, Esquibien, France 29770,

Konstantin Bourdelle, a citizen of Russia residing at
22 Rue du Luiset, Crolles, France 38920, and

Bich-Yen Nguyen, a citizen of the United States residing at
110 S Laurelwood Drive, Austin, Texas 78733

an ASSIGNOR, is an inventor of the invention in **METHOD FOR MANUFACTURING A SEMICONDUCTOR SUBSTRATE**, for which an application for a Patent of the United States, identified by Winston & Strawn LLP Docket No. 4717-31200:

☐ is executed on even date herewith.
☒ was filed on 06-03-2010 as Application No. 12/793,515.

WHEREAS, **S.O.I.TEC SILICON ON INSULATOR TECHNOLOGIES**, a French corporate body having a place of business at Parc Technologique des Fontaines, Chemin des Franques, 38190 Bernin, France, ASSIGNEE, is desirous of obtaining each inventor's entire right, title and interest in, to and under the said invention and the said application.

NOW, THEREFORE, in exchange for good and valuable consideration to each inventor, the receipt and sufficiency of which is hereby acknowledged, each ASSIGNOR has sold, assigned, transferred and set over, and by these presents does hereby sell, assign, transfer and set over, unto the said ASSIGNEE, its successors, legal representatives and assigns, his or her entire right, title and interest in, to and under the invention, and any United States provisional or non-provisional application embodying the invention or any other United States application claiming priority to a provisional application under 35 U.S.C. § 119(e) or converted therefrom, or to any application claiming the benefit of a non-provisional application under 35 U.S.C. § 120, including all divisions, continuations, and continuations-in-part thereof, and all Patents of the United States which may be granted thereon and all reissues and extensions thereof;

And each ASSIGNOR hereby authorizes and requests the Commissioner of Patents and Trademarks of the United States, whose duty it is to issue patents or other evidence or forms of industrial property protection on applications as aforesaid, to issue the same to the ASSIGNEE,

their successors, legal representatives and assigns, in accordance with the terms of this instrument;

And each ASSIGNOR hereby covenants and agrees that he or she has the full right to convey the entire interest herein assigned, and that he or she has not executed, and will not execute, any agreement in conflict herewith;

And each ASSIGNOR hereby further covenants and agrees that he or she will communicate to the ASSIGNEE, their successors, legal representatives and assigns, any facts known to him or her respecting said invention, testify in any legal proceeding, sign all lawful papers, execute all divisional, continuing, reissue and foreign applications, make all rightful oaths, and generally do everything possible to aid the ASSIGNEE, or their successors, legal representatives and assigns, to obtain and enforce proper protection for said invention in all countries;

And each ASSIGNOR hereby authorizes the ASSIGNEE's patent attorney to complete this form by the addition of the application number, application filing date, and attorney docket number, if necessary.

In witness whereof, each inventor has affixed his or her signature.

2010-5-25
Date

Carlos Mazure

On this 25th day of May, 2010, before me appeared Carlos Mazure, to me known and known to me to be the person of that name, who signed the foregoing instrument and acknowledged the same to be his free act and deed.

Witness

Sigrid Huszar
Sigrid HUSZAR
Assistant IP

Date June 3rd 2010 [Signature]
 Richard Ferrant

On this 3rd day of June, 2010, before me appeared Richard Ferrant, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his free act and deed.

[Signature]
 Witness **SIGRID HUSZAR**
 Assistant IP

Date 2010-05-18 [Signature]
 Konstantin Bourdelle

On this 18th day of May, 2010, before me appeared Konstantin Bourdelle, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his free act and deed.

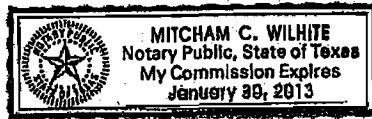
[Signature]
 Witness **SIGRID HUSZAR**
 Assistant IP

May 19, 2010
Date

Bich Yen Nguyen
Bich-Yen Nguyen

STATE OF)
COUNTY OF)

On this 19th day of May, 2010, before me, a Notary Public, personally appeared **Bich-Yen Nguyen**, to me known and known to me to be the person of that name, who signed the foregoing instrument and acknowledged the same to be his free act and deed.



[Signature]
Notary Public